## Notice of References Cited Application/Control No. 10/580,190 Examiner Qiuwen Mi Applicant(s)/Patent Under Reexamination BOMBARDELLI, EZIO Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification 424/778	
*	Α	US-6,379,720	04-2002	Cooper et al.		
*	В	US-6,284,289	09-2001	Van den Berghe, Dirk Andre Richard	424/746	
*	С	US-5,955,102	09-1999	Gorenbein et al. 424		
*	D	US-2003/0064937	04-2003	Nieuwenhuizen et al.	514/27	
*	E	US-6,224,906	05-2001	Ghosal, Shibnath	424/464	
*	F	US-5,370,863	12-1994	Barney et al.	424/49	
*	G	US-6,623,768	09-2003	Naguib, Yousry M. A.	424/773	
	Н	US-			,	
	ı	US-				
	J	US-				
	K-	US-			•	
	L	US-	· · · ·			
	М	US-				

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP406179609	06-1994	Japan -		
	0	CN 1421240 //	06-2003	China		
	Р	FR 2571257	04-1986	France	****	
	α				45	
	R					
	s					
	Т					

## NON-PATENT DOCUMENTS

* Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)					
	υ				
	٧				
	w				
	x				

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.